

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812 Examiner: Mr. Andre C. Stevenson

In re PATENT APPLICATION of

Applicant(s) : Daigo HOSHINO et al

Appln. No. : 10/618,661

Filed : July 15, 2003

For : METHOD OF MEASURING

DEFOCUSING AND METHOD OF

OBTAINING CORRECT FOCUSING

Atty. Dkt. : OKI 360

September 8, 2004

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

Attn: BOX Issue Fee

Sir:

Subsequent to issuance of the Notice of Allowance, dated June 25, 2004, kindly amend the above-identified application as specified on the following pages.

FEE ENCLOSED:\$
Please charge any further
fee to our Deposit Account
No. 18-0002

RABIN & BERDO, P.C. 1101 14th Street, N.W. Suite 500 Washington, DC 20005